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TH 12/22/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Trung T. Doan

Serial No.: 09/133,989

Filed: August 14, 1998

For: CHEMICAL DISPENSING SYSTEM FOR  
SEMICONDUCTOR WAFER PROCESSING

§  
§ Group Art Unit: 1734  
§  
§ Examiner: L. Edwards  
§  
§ Atty. Docket: 93-0421.03  
§  
§  
§  
§

RESPONSE TO THE OFFICE ACTION OF AUGUST 1, 2002

Commissioner for Patents  
Washington, D.C. 20231

Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to:  
Commissioner for Patents, Washington, D.C. 20231, on the date below:

Dear Sir:

12/2/02  
Date

Susan Jerome  
Signature

Applicant herein responds to the Office Action dated August 1, 2002.

REMARKS

Claims 12-33 are pending.

Claims 12-33 are rejected.

Applicant requests the reconsideration of the rejections of claims 12-33 for the reasons discussed below.

I. Rejection of claims under 35 U.S.C. §102

The Examiner rejected various groups of the pending claims as being anticipated by various references. Applicant addresses each basis for rejection separately below.

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DEC 12 2002  
TC 1700 MAIL ROOM

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DEC 17 2003  
TC 1700 MAIL ROOM